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REVISION RECORD		
REV	DESCRIPTION	DATE
H	UPDATED REFERENCE VOLTAGE vs. POST IRRADIATION LIMITS IN TABLE II ELECTRICAL CHARACTERISTICS	12/07/10
I	PAGE 15, UPDATED REFERENCE POST IRRADIATION LIMITS IN TABLE II ELECTRICAL CHARACTERISTICS TO ADD MISSING DROPOUT VOLTAGE FOR “H” PACKAGE.	05/02/11
J	Page 3, amended section 3.3 <u>Special Handling of Dice</u> to more accurately describe our current procedures and requirements.	04/05/12
K	Page 11, Changed RH Canned Sample Table for Qualifying Dice Sales: Subgroup 6 Sample Size Series changed from 45 (3) to 65 (3). First note had the Sample Size Series from “15%” to “10%”.	07/02/13
L	Updated Die Sales table on pg 16.	03/30/15

1.0 SCOPE:

- 1.1 This specification defines the performance and test requirements for a microcircuit processed to a space level manufacturing flow.

2.0 APPLICABLE DOCUMENTS:

- 2.1 Government Specifications and Standards: the following documents listed in the Department of Defense Index of Specifications and Standards, of the issue in effect on the date of solicitation, form a part of this specification to the extent specified herein.

SPECIFICATIONS:

MIL-PRF-38535 Integrated Circuits (Microcircuits) Manufacturing, General Specification for

MIL-STD-883 Test Method and Procedures for Microcircuits

MIL-STD-1835 Microcircuits Case Outlines

- 2.2 Order of Precedence: In the event of a conflict between the documents referenced herein and the contents of this specification, the order of precedence shall be this specification, MIL-PRF-38535 and other referenced specifications.

3.0 REQUIREMENTS:

- 3.1 General Description: This specification details the requirements for the **RH1086BHK, 0.5A and RH1086BKK, 1.5A**, Low Dropout Positive Regulator Dice and Element Evaluation Test Samples, processed to space level manufacturing flow as specified herein.

- 3.2 Part Number:

3.2.1 OPTION 1 – RH1086BHK Dice

3.2.2 OPTION 2 – RH1086BKK Dice

- 3.3 Special Handling of Dice: Rad Hard dice require special handling as compared to standard IC dice. Rad Hard dice are susceptible to surface damage due to the absence of silicon nitride passivation that is present on most standard dice. Silicon nitride protects the dice surface from scratches by its hard and dense properties. The passivation on Linear Technology's Rad Hard dice is silicon dioxide which is much "softer" than silicon nitride. During the visual and preparation for shipment, ESD safe Tweezers are used and only the edge of the die are touched.

LTC recommends that dice handling be performed with extreme care so as to protect the die surface from scratches. If the need arises to move the die in or out of the chip shipment tray (waffle pack), use an ESD-Safe-Plastic-tipped Bent Metal Vacuum Probe, preferably .020" OD x .010" ID (for use with tiny parts). The wand should be compatible with continuous air vacuums. The tip material should be static dissipative Delrin (or equivalent) plastic.

During die attach, care must be exercised to ensure no tweezers, or other equipment, touch the top of the dice.

- 3.4 The Absolute Maximum Ratings:
- | | | |
|--------------------------------------|-----------|--------------------|
| Power Dissipation | | Internally Limited |
| Input to Output Voltage Differential | | 25V |
| Operating Junction Temperature Range | | |
| Control Section | | -55°C to +150°C |
| Power Transistor | | -55°C to +200°C |
| Storage Temperature Range | | -65°C to +150°C |
| Lead Temperature (Soldering, 10 sec) | | 300°C |
- 3.5 Design, Construction, and Physical Dimensions: Detail design, construction, physical dimensions, and electrical requirements shall be specified herein.
- 3.6 Outline Dimensions and Pad Functions: Dice outline dimensions, pad functions, and locations shall be specified in **Figure 1**.
- 3.7 Radiation Hardness Assurance (RHA):
- 3.7.1 The manufacturer shall perform a lot sample test as an internal process monitor for total dose radiation tolerance. The sample test is performed with MIL-STD-883 TM1019 Condition A as a guideline..
- 3.7.2 For guaranteed radiation performance to MIL-STD-883, Method 1019, total dose irradiation, the manufacturer will provide certified RAD testing and report through an independent test laboratory when required as a customer purchase order line item.
- 3.7.3 Total dose bias circuit is specified in **Figure 2**.
- 3.8 Wafer (or Dice) Probe: Dice shall be 100% probed at Ta = +25°C to the limits shown in **Table I** herein. All reject dice shall be removed from the lot. This testing is normally performed prior to dicing the wafer into chips. Final specifications after assembly are sample tested during the element evaluation.
- 3.9 Wafer Lot Acceptance: Wafer lot acceptance shall be in accordance with MIL-PRF-38535, Appendix A, except for the following: Top side glassivation thickness shall be a **minimum of 4KÅ**.
- 3.10 Wafer Lot Acceptance Report: SEM is performed per MIL-STD-883, Method 2018. Copies of SEM photographs shall be supplied with the Wafer Lot Acceptance Report as part of a Space Data Pack when specified as a customer purchase order line item.
- 3.11 Traceability: Wafer Diffusion Lot and Wafer traceability shall be maintained through Quality Conformance Inspection.
- 4.0 **QUALITY CONFORMANCE INSPECTION:** Quality Conformance Inspection shall consist of the tests and inspections specified herein.
- 5.0 **SAMPLE ELEMENT EVALUATION:** A sample from **each wafer supplying dice** shall be assembled and subjected to element evaluation per **Table III** herein.
- 5.1 100 Percent Visual Inspection: All dice supplied to this specification shall be inspected in accordance with MIL-STD-883, Method 2010, Condition A. All reject dice shall be removed from the lot.

- 5.2 Electrical Performance Characteristics for Element Evaluation: The electrical performance characteristics shall be as specified in **Table I** and **Table II** herein.
- 5.3 Sample Testing: Each wafer supplying dice for delivery to this specification shall be subjected to element evaluation sample testing. No dice shall be delivered until all the lot sample testing has been performed and the results found to be acceptable unless the customer supplies a written approval for shipment prior to completion of wafer qualification as specified in this specification.
- 5.4 Part Marking of Element Evaluation Sample Includes:
- 5.4.1 LTC Logo
 - 5.4.2 LTC Part Number
 - 5.4.3 Date Code
 - 5.4.4 Serial Number
 - 5.4.5 ESD Identifier per MIL-PRF-38535, Appendix A
 - 5.4.6 Diffusion Lot Number
 - 5.4.7 Wafer Number
- 5.5 Burn-In Requirement: Burn-In circuit for TO39 package is specified in **Figure 3** and Burn-In circuit for TO3 package is specified in **Figure 4**.
- 5.6 Mechanical/Packaging Requirements: Case Outline and Dimensions are in accordance with **Figure 5** and **Figure 6**.
- 5.7 Terminal Connections: The terminal connections shall be as specified in **Figure 7** and **Figure 8**.
- 5.8 Lead Material and Finish: The lead material and finish shall be Kovar for device option 1 and Alloy 52 for device option 2, with hot solder dip (Finish letter A) in accordance with MIL-PRF-38535.

6.0 VERIFICATION (QUALITY ASSURANCE PROVISIONS)

- 6.1 Quality Assurance Provisions: Quality Assurance provisions shall be in accordance with MIL-PRF-38535. Linear Technology is a QML certified company and all Rad Hard candidates are assembled on qualified Class S manufacturing lines.
- 6.2 Sampling and Inspection: Sampling and Inspection shall be in accordance with **Table III** herein.
- 6.3 Screening: Screening requirements shall be in accordance with **Table III** herein.
- 6.4 Source Inspection:
- 6.4.1 The manufacturer will coordinate Source Inspection at wafer lot acceptance and pre-seal internal visual.
 - 6.4.2 The procuring activity has the right to perform source inspection at the supplier's facility prior to shipment for each lot of deliverables when specified as a customer purchase order line item. This may include wafer lot acceptance, die visual, and final data review.

6.5 Deliverable Data: Deliverable data that will ship with devices when a Space Data Pack is ordered:

- 6.5.1 Lot Serial Number Sheets identifying all Canned Sample devices accepted through final inspection by serial number.
- 6.5.2 100% attributes (completed element evaluation traveler).
- 6.5.3 Element Evaluation variables data, including Burn-In and Op Life
- 6.5.4 SEM photographs (3.10 herein)
- 6.5.5 Wafer Lot Acceptance Report (3.9 herein)
- 6.5.6 A copy of outside test laboratory radiation report if ordered
- 6.5.7 Certificate of Conformance certifying that the devices meet all the requirements of this specification and have successfully completed the mandatory tests and inspections herein.

Note: Items 6.5.1 and 6.5.7 will be delivered as a minimum, with each shipment.

7.0 Packaging Requirements: Packaging shall be in accordance with Appendix A of MIL-PRF-38535. All dice shall be packaged in multicavity containers composed of conductive, anti-static, or static dissipative material with an external conductive field shielding barrier.

DICE OUTLINE DIMENSIONS AND PAD FUNCTIONS
OPTION 1, RH1086BHK, 0.5A DICE AND OPTION 2, RH1086BKK, 1.5A DICE

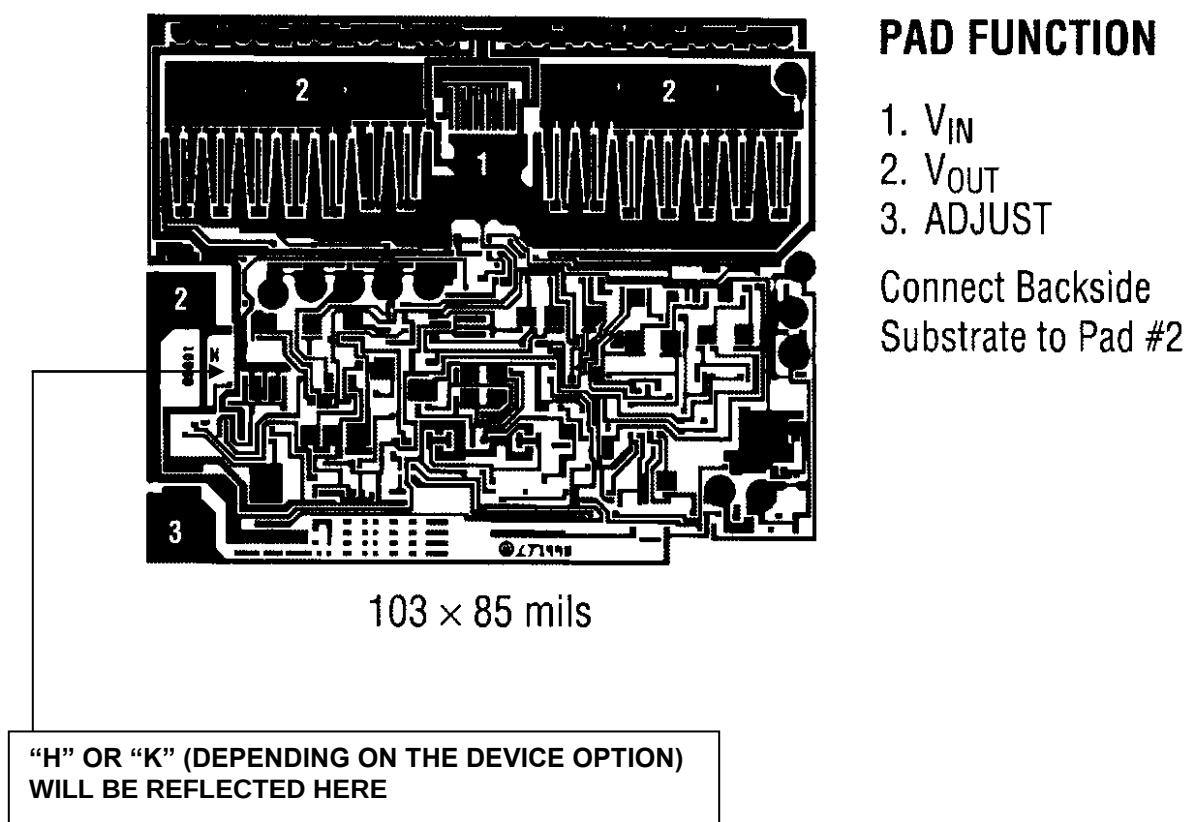
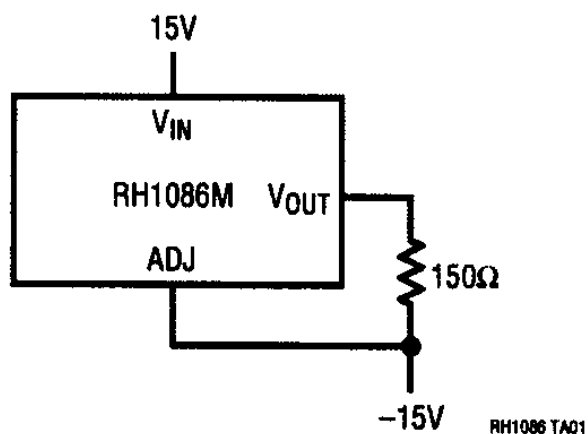
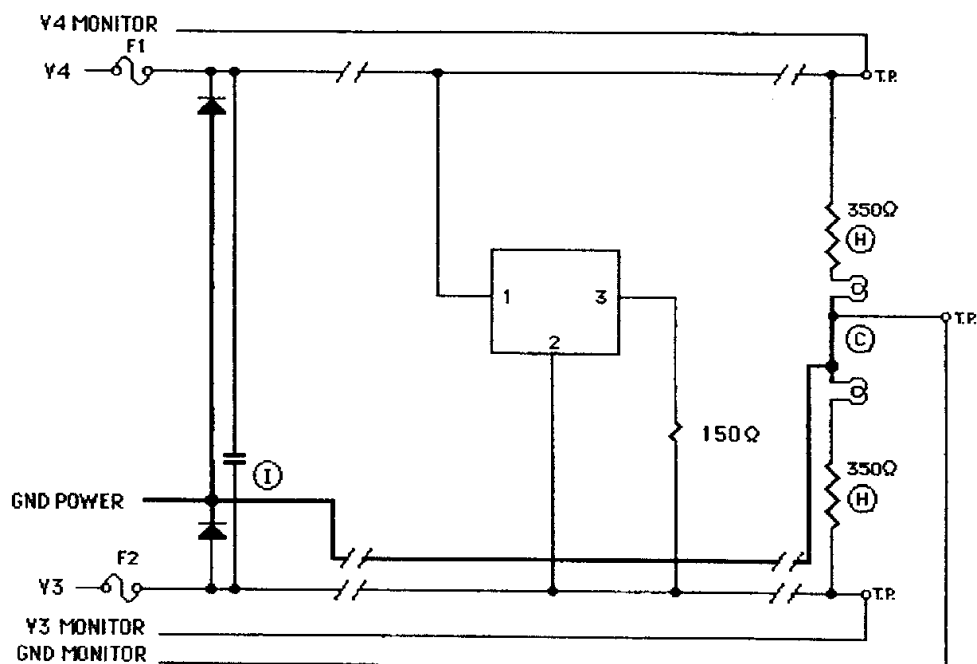


FIGURE 1

TOTAL DOSE BIAS CIRCUITFIGURE 2

TO39 STATIC BURN-IN CIRCUIT
OPTION 1, T039 METAL CAN / 3 LEADS**NOTES:**

1. Unless otherwise specified, component tolerances shall be per military specification.
2. $T_j = 174^\circ\text{C}$ maximum.
3. $T_a = 125^\circ\text{C}$.
4. Burn-in Voltages: $Y4 = +15\text{V to } +16.5\text{V}$
 $Y3 = -15\text{V to } -16.5\text{V}$

3 PIN TO-39

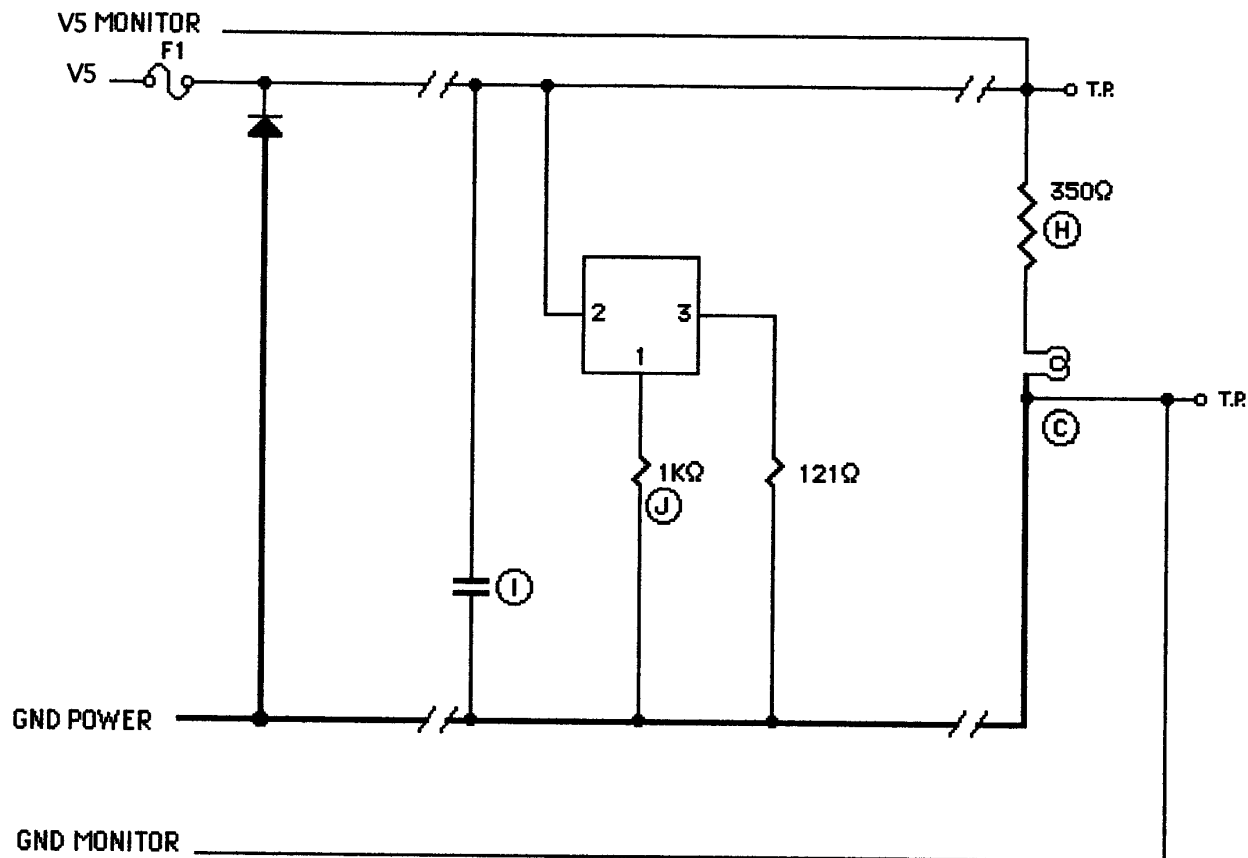


TOP VIEW

1. V_{in}
2. Adjust
3. Output (case)

PACKAGE AND PINOUT

FIGURE 3

STATIC BURN-IN CIRCUIT
OPTION #2, TO3 / 2 LEADS

NOTES:

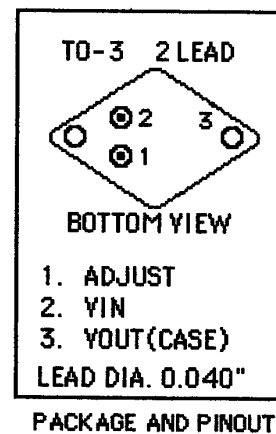
Unless otherwise specified, component tolerances shall be per military specification.

For RH1086:

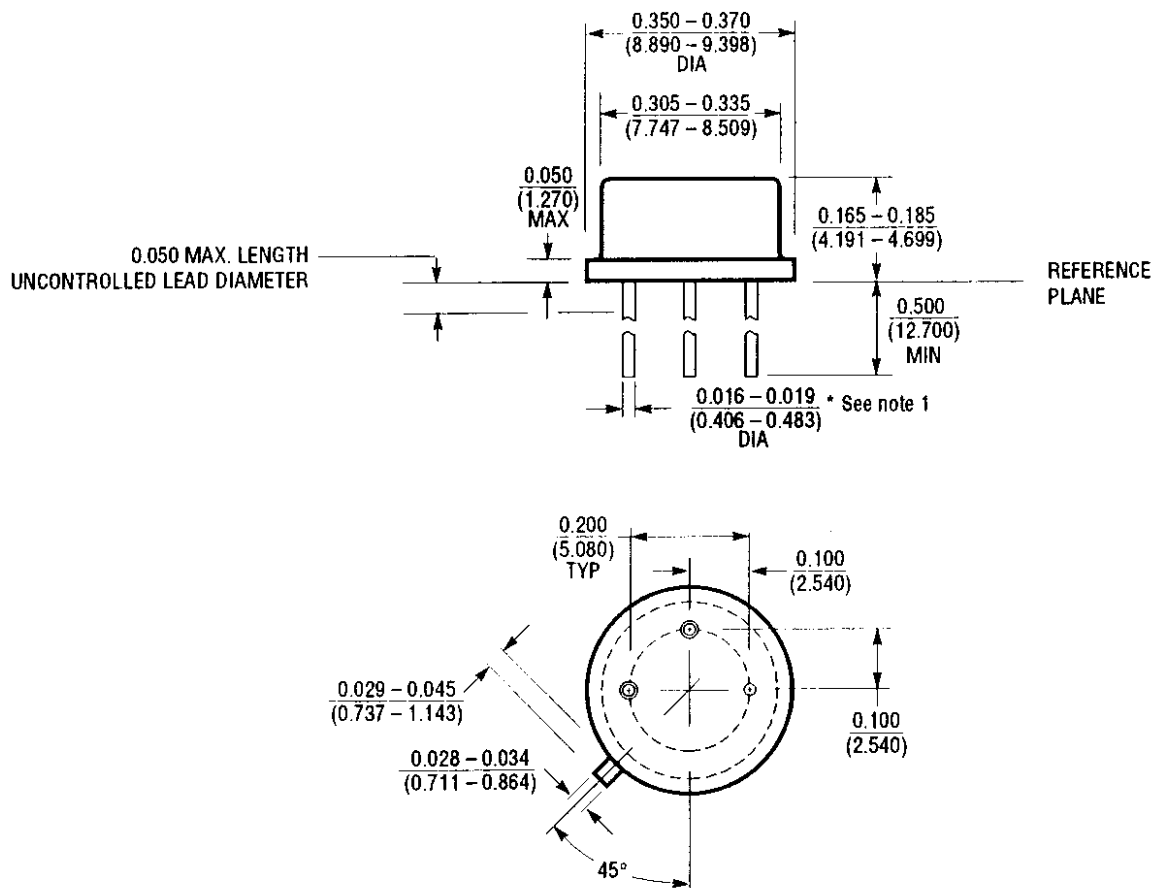
Burn-In Voltage to be V5 = +23V to +25V

T_j = 168 °C max at T_a of 150 °C.

T_j = 143 °C max at T_a of 125 °C.

FIGURE 4

DEVICE OPTION # 1
(H) TO39 METAL CAN / 3 LEADS CASE OUTLINE



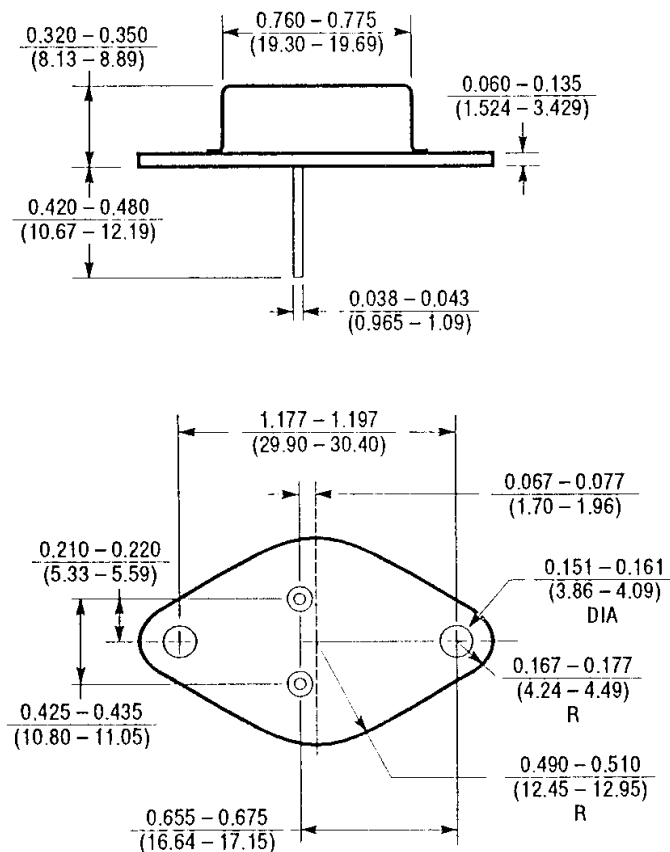
NOTE: 1. FOR SOLDER DIP LEAD FINISH, LEAD DIAMETER IS $\frac{0.016 - 0.024}{(0.406 - 0.610)}$

FIGURE 5

$\theta_{ja} = +150^{\circ}\text{C/W}$

$\theta_{jc} = +40^{\circ}\text{C/W}$

DEVICE OPTION # 2
(K) TO3 METAL CAN / 2 LEADS CASE OUTLINE



$$\theta_{ja} = +35^{\circ}\text{C/W}$$

$$\theta_{jc} = +3^{\circ}\text{C/W}$$

FIGURE 6

TERMINAL CONNECTIONS
DEVICE OPTION #1, TO39 / 3 LEAD METAL CAN

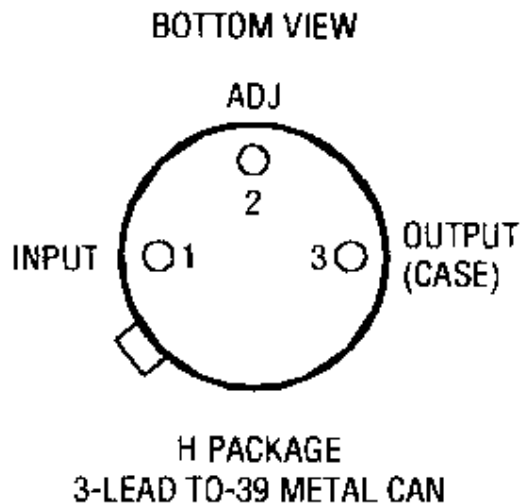


FIGURE 7

DEVICE OPTION #2, TO3 / 2 LEAD METAL CAN

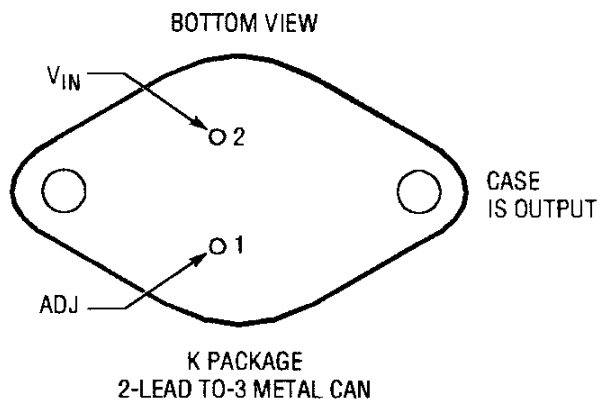


FIGURE 8

TABLE I DICE ELECTRICAL CHARACTERISTICS – Element Evaluation (Note 1)

PARAMETER	CONDITIONS	RH1086K (Note 6)		RH1086H (Note 6)		UNITS
		MIN	MAX	MIN	MAX	
Reference Voltage	$I_{OUT} = 10\text{mA}$, $T_J = 25^\circ\text{C}$, $(V_{IN} - V_{OUT}) = 3\text{V}$ $1.5\text{V} \leq (V_{IN} - V_{OUT}) = 15\text{V}$	1.238	1.262			V
		1.225	1.270	1.225	1.270	V
Line Regulation	$I_{LOAD} = 10\text{mA}$, $1.5\text{V} \leq (V_{IN} - V_{OUT}) \leq 15\text{V}$ $T_J = 25^\circ\text{C}$		0.2		0.2	%
Load Regulation	$(V_{IN} - V_{OUT}) = 3\text{V}$, $10\text{mA} \leq I_{OUT} \leq 1.5\text{A}$ $T_J = 25^\circ\text{C}$ (0.5A for RH1086H) (Notes 1, 2, 5, 6)		0.3		0.3	%
Dropout Voltage ($V_{IN} - V_{OUT}$)	ΔV_{OUT} , $\Delta V_{REF} = 1\%$, $I_{OUT} = 1.5\text{A}$ (0.5A for RH1086H) (Notes 3, 5, 6)		1.5		1.25	V
Current Limit	$(V_{IN} - V_{OUT}) = 5\text{V}$	1.5		0.5		A
	$(V_{IN} - V_{OUT}) = 25\text{V}$ (Note 5)	0.050		0.020		A
Minimum Load Current	$(V_{IN} - V_{OUT}) = 25\text{V}$ (Note 4)		10		10	mA
Ripple Rejection	$f = 120\text{Hz}$, $C_{OUT} = 25\mu\text{F}$ Tantalum $I_{OUT} = 1.5\text{A}$, ($I_{OUT} = 0.5\text{A}$ for RH1086H) $C_{ADJ} = 25\mu\text{F}$, $(V_{IN} - V_{OUT}) = 3\text{V}$ (Note 5, 6)	60		60		dB
Adjust Pin Current	$T_J = 25^\circ\text{C}$		120		120	μA
Adjust Pin Current Change	$10\text{mA} \leq I_{OUT} \leq 1.5\text{A}$ (0.5A for RH1086H) $1.5\text{V} \leq (V_{IN} - V_{OUT}) \leq 15\text{V}$ (Note 5, 6)		5		5	μA

Note 1: See thermal regulation specifications for changes in output voltage due to heating effects. Load and line regulation are measured at a constant junction temperature by low duty cycle pulse testing. Load regulation is measured at the output lead $\approx 1/8"$ from the package.

Note 2: Line and load regulation are guaranteed up to the maximum power dissipation of 15W for the RH1086K, 3W for the RH1086H. Power dissipation is determined by the input/output differential and the output current. Guaranteed maximum power dissipation will not be available over the full input/output voltage range. See Short Circuit Current Curve in the LT1086 Series standard data sheet for available output current.

Note 3: Dropout voltage is specified over the full output current range of the device. Test points and limits are shown on the Dropout Voltage Curve in the LT1086 Series standard data sheet.

Note 4: Minimum load current is defined as the minimum output current required to maintain regulation. At 25V input/output differential the device is guaranteed to regulate if the output current is greater than 10mA.

Note 5: Guaranteed by design but not tested at wafer sort.

Note 6: For compliance with 883 revision C current density spec. RH1086K is derated to 1.0A max load operation.

TABLE II ELECTRICAL CHARACTERISTICS (POSTIRRADIATION)**T_A = 25°C unless otherwise noted.**

PARAMETER	CONDITIONS	10KRAD (Si)		20KRAD (Si)		50KRAD (Si)		100KRAD (Si)		200KRAD (Si)		UNITS
		MIN	MAX	MIN	MAX	MIN	MAX	MIN	MAX	MIN	MAX	
Reference Voltage (Note 6)	$I_{OUT} = 10\text{mA}$ ($V_{IN} - V_{OUT} = 3\text{V}$ (K))	1.234	1.262	1.230	1.262	1.225	1.262	1.220	1.262	1.205	1.262	V
	$10\text{mA} \leq I_{OUT} \leq I_{FULL\ LOAD}$ $1.5\text{V} \leq (V_{IN} - V_{OUT}) \leq 15\text{V}$	1.220	1.275	1.219	1.275	1.215	1.275	1.210	1.275	1.20	1.275	V
Line Regulation (Notes 2, 3)	$I_{OUT} = 10\text{mA}$ $1.5\text{V} \leq (V_{IN} - V_{OUT}) \leq 15\text{V}$		0.2		0.21		0.23		0.25		0.3	%
Load Regulation (Notes 2, 3, 6)	$(V_{IN} - V_{OUT}) = 3\text{V}$ $10\text{mA} \leq I_{OUT} \leq I_{FULL\ LOAD}$		0.3		0.3		0.3		0.3		0.3	%
Dropout Voltage (Note 4)	$\Delta V_{REF} = 1\%$, $I_{OUT} = 1.5\text{A}$ (K)		1.5		1.51		1.52		1.55		1.575	V
	$\Delta V_{REF} = 1\%$, $I_{OUT} = 0.5\text{A}$ (H)		1.25		1.26		1.27		1.29		1.32	V
Current Limit	$(V_{IN} - V_{OUT}) = 5\text{V}$ (K)	1.5		1.5		1.5		1.5		1.5		A
	$(V_{IN} - V_{OUT}) = 25\text{V}$ (K)	0.05		0.049		0.048		0.047		0.045		A
	$(V_{IN} - V_{OUT}) = 5\text{V}$ (H)	0.5		0.5		0.5		0.5		0.5		A
	$(V_{IN} - V_{OUT}) = 25\text{V}$ (H)	0.020		0.019		0.019		0.018		0.017		A
Minimum Load Current	$(V_{IN} - V_{OUT}) = 25\text{V}$		10		10		10		10		10	mA
Adjust Pin Current			120		120		120		120		120	μA
Adjust Pin Current Change (Note 6)	$10\text{mA} \leq I_{OUT} \leq I_{FULL\ LOAD}$ $1.5\text{V} \leq (V_{IN} - V_{OUT}) \leq 15\text{V}$		5		5		5		5		5	μA

Note 1: Stresses beyond those listed under Absolute Maximum Ratings may cause permanent damage to the device. Exposure to any Absolute Maximum Rating condition for extended periods may affect device reliability and lifetime.

Note 2: See thermal regulation specifications for changes in output voltage due to heating effects. Line and load regulation are measured at a constant junction temperature by low duty cycle pulse testing.

Note 3: Line and load regulation are guaranteed up to the maximum power dissipation of 15W for RH1086MK and 3W for the RH1086MH. Power dissipation is determined by the input/output differential voltage and the output current. Guaranteed maximum power dissipation will not be available over the full input/output voltage range.

Note 4: Dropout voltage is specified over the full output current range of the device. Test points and limits are shown on the Dropout Voltage curve in the LT*1086 data sheet.

Note 5: Guaranteed by design, characterization, or correlation to other tested parameters.

Note 6: $I_{FULL\ LOAD}$ is defined in the Current Limit curves in the standard data sheet. For compliance with 883 revision C current density specifications, the RH1086MK is derated to 1A.



RH CANNED SAMPLE TABLE FOR QUALIFYING DICE SALES

TABLE III RH ELEMENT EVALUATION TABLE QUALIFICATION OF DICE SALES

SUBGROUP	CLASS			OPERATION	MIL-STD-883		QUANTITY (ACCEPT NUMBER)
	K/S	V	H/B		METHOD	CONDITION	
1	X	X		SEM	2018	N/A	REF. METHOD 2018 FOR S/S
2	X	X	X	ELEMENT ELECTRICAL (WAFER SORT @ 25°C)			100%
3	X	X	X	ELEMENT VISUAL (2nd OP)	2010	A	100%
4	X	X	X	INTERNAL VISUAL (3rd OP)	2010	A	ASSEMBLED PARTS ONLY
	X	X		DIE SHEAR MONITOR	2019		
	X	X		BOND PULL MONITOR	2011		
5	X	X		STABILIZATION BAKE	1008	C	ASSEMBLED PARTS ONLY
	X	X		TEMPERATURE CYCLE	1010	C	
	X	X		CONSTANT ACCELERATION	2001	E	
	X	X		FINE LEAK	1014	A	
	X	X		GROSS LEAK	1014	C	
6	X	X		FIRST ROOM ELECTRICAL - READ & RECORD (REPLACE ANY ASSEMBLY-RELATED REJECTS)			45(0)
	X	X		PRE BURN-IN ELECT. READ & RECORD @ +125°C or +150°C, -55°C			
	X	X		BURN-IN: +125°C/240 hrs. or +150°C/120 hrs.	1015	+ 125°C MINIMUM 240 HOURS	
	X	X		POST BURN-IN ELECT. READ & RECORD @ 25°C			
	X	X		POST BURN-IN ELECT. READ & RECORD @ +125°C or +150°C, -55°C			
	X	X		TOTAL IRRADIATION DOSE	1019	A	
	X	X		PRE OP-LIFE ELECTRICAL @ 25°C READ & RECORD			
	X	X		OPERATING LIFE: +125°C/1000 hrs. or +150°C/500 hrs.	1005	+ 125°C MINIMUM 1000 HOURS	
	X	X		POST OP-LIFE ELECT. (R & R @ 25°C, +125°C OR +150°C, -55°C			
7	X	X	X	WIRE BOND EVALUATION	2011		15(0) OR 25(1) - # of wires

NOTE: LTC is not qualified to process to MIL-PRF-38534. This is an LTC imposed element evaluation that follows MIL-STD-883 test methods and conditions. Please note the quantity and accept number from Sample Size Series of 5%, accept on 0, and note that the actual sample and accept number does not begin until Subgroup 6 OP-LIFE.

NOTE: Tests within Subgroup 5 may be performed in any sequence.

NOTE: LTC's radiation tolerance (RH) die has a topside glassivation thickness of 4KA minimum.

NOTE: Sample sizes on the travelers may be larger than that indicated in the above table; however, the larger sample size is to accommodate extra units for replacement devices in the event of equipment or operator error and for assembly related rejects in Subgroup 6, and for Wire Bond Evaluation, Subgroup 7. The larger sample size is at all times kept segregated and, if used for qualification, has all the required processing imposed.